

Notice of References Cited	Application/Control No. 10/601,090	Applicant(s)/Patent Under Reexamination VISCOR ET AL.
	Examiner Zia R. Hashmi	Art Unit 2881

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,280,221	01-1994	Okamoto et al.	315/169.1
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Birecki, et al, " Planar Electron Emitter Apparatus with Improved Emission Area and Method of Manufacture", Pub. No: US 2003/0128647 A1, Publication date: July 10, 2003.
	V	Delong et al., " A 1:1 Electron Stepper", J. Vac. Sci. Technol. B7(6) Nov/Dec 1989, Pp 1422-1425.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.